



03/27/03

1763

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor : Tatsuya SUZUKI

Serial No. : 09/823,058

Filed : March 30, 2001

Title : **STOCK/TRANSFER VESSEL FOR  
SEMICONDUCTOR SUBSTRATE AND METHOD  
OF MANUFACTURING SEMICONDUCTOR  
DEVICE**

Examiner : Karla A. Moore

Group Art Unit : 1763

Filed by Express

Receipt No. CV115066162945

Mar 26-03

Pursuant to 37 C.F.R. 1.10.

by [Signature]  
PATENT & TRADEMARK OFFICE

Commissioner for Patents  
Washington, D.C. 20231

**RESPONSE TO OFFICE ACTION**

Sir:

In response to the Office Action dated December 26, 2002, please amend the  
subject application as follows:

**IN THE CLAIMS**

**Please cancel claims 3 and 13 without prejudice or disclaimer.**

**Please amend claims 1 and 10 as follows:**

1. (Amended) A semiconductor substrate stock/transfer vessel, which is an  
openable/closeable sealed vessel used in a semiconductor device manufacturing process  
and adapted to store or transfer a semiconductor substrate,

March 26, 2003

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